


APPLICATION DATA SHEET

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Title of Invention	PHOTOLITHOGRAPHY SYSTEM WITH VARIABLE SHUTTER AND METHOD OF USING THE SAME	
Application Type : regular, utility Attorney Docket Number : LKSP0041USA		
Correspondence address: Customer Number: 027765 		
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as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.